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SERIAL NUMBER 10/588,283	FILING or 371(c) DATE 07/23/2007 RULE	CLASS 428	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. S8810.0003/P003		
APPLICANTS Masashi Kawasaki, Miyagi, JAPAN; Akira Ohtomo, Miyagi, JAPAN; Tomoaki Fukumura, Miyagi, JAPAN; Atsushi Tsukazaki, Miyagi, JAPAN; Makoto Ohtani, Miyagi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/13246 09/10/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2004-031194 02/06/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED *** SMALL ENTITY ** 02/04/2008						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/JOEL G HORNING/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 10	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 3
ADDRESS DICKSTEIN SHAPIRO LLP 1825 EYE STREET NW Washington, DC 20006-5403 UNITED STATES						
TITLE Method of Manufacturing Thin Film, Method of Manufacturing P-Type Zinc Oxide Thin Film and Semiconductor Device						
FILING FEE RECEIVED 1425	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			